Notice of References Cited Application/Control No. | Applicant(s)/Patent Under | Reexamination | HIATT ET AL. | Examiner | Art Unit | Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,008,102	12-1999	Alford et al.	29/602.1 x
	В	US-			
	С	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-	2		
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 64-42110	02-1980	Japan	Shiiki et al	29/602.1 x
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	R					
	S		•			
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	υ	Littwin, B., "Buuble Circuit Fabrication by Electrodeposition", IEEE Transactions on Magnetics, Vol. 1 Mag-11, No. 5, September 1975, pages 1139-1141.			
	V				
	w				
	х				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.